## Supplementary Information

## The surface reconstruction induced enhancement of the oxygen evolution reaction on α-SnWO<sub>4</sub> (010) based on a density functional theory study

Wentao Wang<sup>\*1</sup>, Yonggang Wu<sup>\*2</sup>, Deliang Chen<sup>2</sup>, Hongling Liu<sup>2</sup>, Mei Xu<sup>3</sup>, Xuefei Liu<sup>3</sup>, Lipeng Xin<sup>\*4</sup>

<sup>1</sup>Guizhou Provincial Key Laboratory of Computational Nano-Material Science, Guizhou Education University, Guiyang 550018, China

<sup>2</sup> School of Physics and Electronic Science, Guizhou Education University, Guiyang 550018,

## China

<sup>3</sup>School of Physical and Electronic Sciences, Guizhou Normal University, Guiyang 550025, China

<sup>4</sup>Frontier Institute of Science and Technology, Xi'an Jiaotong University, Xi'an 710049, China \*E-mail: wuli8@163.com (W. Wang, <u>https://orcid.org/0000-0003-4308-3515</u>);





**Fig. S1.** Side view of three possible stoichiometric structures of  $\alpha$ -SnWO<sub>4</sub> (010): (a) ST1, (c) ST2, and (e) ST3 are the structures before optimization, and (b), (d), and (f) are after optimization, respectively. The red, gray and light blue balls represent O, W, and Sn atoms.



**Fig. S2.** Variations of temperature and energy plotted as a function of time for AIMD simulations of (a) ST1 (b)ST2, and (c)ST3 terminations under 300 K for 8 ps with a time step of 1 fs. The right parts show the termination structures at 0 ps and 8 ps.



Fig. S3. (a) The  $\Delta\mu_0$  as a function of oxygen gas pressure at various temperatures according to Equation (20), (b) the phase diagrams for  $\alpha$ -SnWO<sub>4</sub> (010) surface with different terminations (including O-Sn term., M-Sn term., R-OOW term., O-W term., W-O term., R-OOSn term., and ST3 term.) as functions of chemical potential variations for Sn and oxygen atoms, (c) the  $\Delta\mu_0$  as a function of temperature at various oxygen gas pressures. All total energies are obtained using the PBE method.



Fig. S4. Surface Gibbs free energies as a function of  $\Delta \mu_{\text{Sn}}$  at a certain temperature and pressure for  $\alpha$ -SnWO<sub>4</sub> (010) surface using the PBE method (a) at T = 300K and (b) T = 1000K.



Fig. S5. The (a)Band structures, (b)TDOS and PDOS of bulk  $\alpha$ -SnWO<sub>4</sub> are obtained from HSE06 calculations. The Fermi level is set to zero and indicated by the red dotted-dashed line.





(c) R-OOSn term.



density of states	3	1st-layer		0
	0 3 0 0 3 0 3 0 0 0 3 0 0 0 0 0 0 0 0 0 0 0 0 0	2nd-layer	Ŵ	0
		3rd-layer		Sn
		4th-layer		0
		5th-layer		0
		6th-layer		MM-w
		7th-layer		Sn
		8th-layer	~	0
		9th-layer	L	Sn
	°3	10th-layer	A	0
	3 0	11th-layer		0
	3	12th-layer		MM_w
	3 0	13th-layer		0
	3 0	14th-layer		0
	3 0			
	3 0	17th laver		0
	3 0	8 -6 -4 -2		0
Energy (eV)				





Fig. S6. The layer-resolved density of states of (a) O-Sn term., (b) O-W term. (c) R-OOSn term. and ST3 term., for SnWO<sub>4</sub> (010) surfaces, which are obtained from HSE06 calculations. The Fermi level is set to zero and indicated by a perpendicular red dot-dash line. The numbers represent the number of atomic layers for  $\alpha$ -SnWO<sub>4</sub> (010) surfaces





Fig. S7. The optimized structures for O\*, OH\*, and OOH\* intermediates on the O-Sn termination of  $\alpha$ -SnWO<sub>4</sub> (010) surfaces at different (a) and (b) sites.



Fig. S8. The free energy profile for OER on the ST3 termination of  $\alpha$ -SnWO4(010) surface at different voltages. The optimized structures for O\*, OH\* and OOH\* intermediates on the (b)ST3 termination of  $\alpha$ -SnWO<sub>4</sub> (010) surfaces.

## Note S1 Computational hydrogen electrode

For the OER reaction, four elementary steps are usually needed to proceed, as listed in equations (1) to (4), which involve adsorbed OH, O and OOH species on the surface (\*):

$$2H_2O + * \rightarrow HO^* + H^+ + H_2O + e^-$$
(S1)

$$OH^* + H_2O \rightarrow O^* H_2O + H^+ + e^-$$
(S2)

$$H_2O + O^* \to HOO^* + H^+ + e^-$$
(S3)

$$HOO^* \rightarrow O_2 + * + H^+ + e^-$$
(S4)

The above mechanism is the most common one of the water-splitting on semiconductor surfaces. It involves the dehydrogenation of  $H_2O$ , followed by the dissociation of HO\* to O\*. Subsequently, O\* reacts with another  $H_2O$  to generate HOO\*, which then dehydrogenates to  $O_2$ .

The Gibbs free energy change for steps 1-4 can be expressed as

$$\Delta G_1 = \Delta G(OH_{ads}) - eU + \Delta G_{H^+}(pH)$$
(S5)

$$\Delta G_2 = \Delta G(O_{ads}) - \Delta G(OH_{ads}) - eU + \Delta G_{H^+}(pH)$$
(S6)

$$\Delta G_3 = \Delta G(OOH_{ads}) - \Delta G(O_{ads}) - eU + \Delta G_{H^+}(pH)$$
(S7)

$$\Delta G_4 = 4.92 - \Delta G(OOH_{ads}) - eU + \Delta G_{H+}(pH)$$
(S8)

where U is the potential measured against normal hydrogen electrode (NHE) at standard conditions (T = 298.15 K, P = 1 bar, pH = 0). The free energy change of the protons relative to the above specified electrode at non-zero pH is represented by Nernst equation as  $\Delta G_{H^+}(pH) = -k_B T \ln(10) \times pH$ . The sum of  $\Delta G_{1-4}$  is fixed to the negative of experimental Gibbs free energy of formation of two water molecules  $^{-2 \Delta g} g_{H_2O}^{exp} = 4 \times 1.23 = 4.92$  eV to avoid calculating the O bond energy, which is difficult to determine accurately within GGA-DFT. The Gibbs free energies of eqs 5–8 depend on the adsorption energies of OH\*, O\*, and OOH\*. To compute the free energy change ( $\Delta G$ ) of each elementary step of electrochemical urea synthesis, we adopted the computational hydrogen electrochemical reaction is defined as:  $\Delta G_i = \Delta E_i + \Delta ZPE_i - T\Delta S_i$ , where i means OH\*, O\* and OOH\*. ZPE and S are the zero-point energy and entropy corrections, respectively. The energy differences  $\Delta E_i$  calculated relative to H<sub>2</sub>O and H<sub>2</sub> (at U = 0 and pH = 0) as

$$\Delta E_{DFT}(OH^*) = E_{DFT}(OH^*) - E(^*) - [E_{DFT}(H_2O) - 1/2^*E_{DFT}(H_2)]$$
(S9)

$$\Delta E_{DFT} (O^*) = E_{DFT} (O^*) - E(^*) - [E_{DFT} (H_2 O) - E_{DFT} (H_2)]$$
(S10)

$$\Delta E_{DFT} (OOH^*) = E_{DFT} (OOH^*) - E(^*) - [2^* E_{DFT} (H_2O) - 3/2^* E_{DFT} (H_2)]$$
(S11)

The theoretical overpotential is then readily defined as:

$$\eta = \max[\Delta G_1, \Delta G_2, \Delta G_3, \Delta G_4]/e-1.23[V]$$
(S12)

The entropies of gas-phase  $H_2$  is obtained from the NIST database<sup>2</sup> with the standard condition, and the adsorbed species were only taken vibrational entropy (Sv) into account, as shown in the following formula:

$$S_{V} = \sum_{i} R \left\{ \frac{hv_{i}}{k_{B}T} \left[ exp\left(\frac{hv_{i}}{k_{B}T}\right) - 1 \right]^{-1} - \ln \left[ 1 - exp\left(-\frac{hv_{i}}{k_{B}T}\right) \right] \right\}$$
(S13)

Among which R = 8.314 J·mol<sup>-1</sup>·K<sup>-1</sup>, T = 298.15 K, h = 6.63 ×10<sup>-34</sup> J·s, k<sub>B</sub> =  $1.38 \times 10^{-23}$  J·K<sup>-1</sup>, i is the frequency number, v<sub>i</sub> is the vibrational frequency (unit is cm<sup>-1</sup>).

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